

Docket No.: 1592-0178PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Masanori SAKAI et al.

Application No.: 10/549,698

Confirmation No.: 9561

Filed: July 14, 2006

Art Unit: 1792

For: SUBSTRATE PROCESSING APPARATUS
AND PRODUCING METHOD OF
SEMICONDUCTOR DEVICE

Examiner: K. T. Chen

AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Madam:

INTRODUCTORY COMMENTS

In response to the final Office Action dated August 6, 2009, please amend the above-identified U.S. patent application as follows.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.